

<b>Notice of References Cited</b>	Application/Control No. 10/562,080		Applicant(s)/Patent Under Reexamination DEGUCHI ET AL.	
	Examiner Mark John Stevenosky, Jr.		Art Unit 2853	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0090483	05-2004	Gue et al.	347/020
*	B	US-2001/0017639	08-2001	Noguchi et al.	347/45
*	C	US-6,368,515	04-2002	Kaminishi et al.	216/27
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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